

PATENT APPLICATION  
Docket No.: 9898-314  
Client Ref. No.: SS-20035-US

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of: Won-Jun LEE, et al.

Serial No.: 10/763,356 Examiner: Anita Karen Alanko

Filed: January 23, 2004 Group Art Unit: 1765

Confirmation No.: 7097

For: ETCHING METHOD FOR MANUFACTURING SEMICONDUCTOR  
DEVICE

Date: February 27, 2007

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT**

Responsive to the Office Action, Paper No. 20061124, dated November 30, 2006, please amend the application as follows.

**Amendments to the Claims** are reflected in the listing of claims, which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 5 of this paper.